



Docket No.: 1793.1110

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Joon-Ho CHA, et al.

Serial No. 10/719,021

Group Art Unit: 2828

Confirmation No. 9169

Filed: November 24, 2003

Examiner: Tod T. VAN ROY

For: LASER DIODE FOR OPTICAL PICKUP AND METHOD OF PROTECTION

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

A Request for Continued Examination is being filed along with this Amendment in further response to the Office Action mailed March 20, 2006, and having a period for response set to expire on June 20, 2006.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.